## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Wang et. al.

Serial No.: Not Yet Assigned

**Filed:** July 14, 2003

For: SEMICONDUCTOR FUSES, METHODS OF USING AND MAKING THE SAME, AND SEMICONDUCTOR DEVICES CONTAINING THE SAME

Confirmation No.: Unknown

Examiner: Unknown

Group Art Unit: Unknown

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(97-0855.03/US)

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## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The present application is a divisional of application Serial No. 10/331,033, filed December 27, 2002, pending, which is a continuation of application Serial No. 09/901,761, filed July 9, 2001, now U.S. Patent 6,511,868, issued January 28, 2003, which is a continuation of application Serial No. 09/165,754, filed October 2, 1998, now U.S. Patent 6,277,674, issued August 21, 2001.

Pursuant to M.P.E.P. 2001.06(b), the Examiner is respectfully requested to consider the information of record in the three prior applications, and to confirm in the first Office Action on

## Attorney Docket No. 2269-3541.3US

the merits that such art has in fact been reviewed. A PTO-1449 or PTO/SB/08 form listing all of the information of record in the prior applications is enclosed herewith.

This Information Disclosure Statement is filed within three (3) months of the filing date of the above-identified application, and no certification pursuant to 37 C.F.R. § 1.97(c) or a fee pursuant to 37 C.F.R. 1.17(p) is required.

Respectfully submitted,

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Enclosures: Form PTO-1449 or PTO/SB/08

Document in ProLaw

(2 02)

Sheet 1 of 1 Form PTO-1449 Docket Number (Optional) **Application Number** 3541.3US (97-0855.03/US) **Not Yet Assigned** INFORMATION DISCLOSURE CITATION **Applicant** Wang et al. IN AN APPLICATION (Use several sheets if necessary) Filing Date July 14, 2003 Group Art Unit Unknown **U.S. PATENT DOCUMENTS EXAMINER** FILING DATE DOCUMENT NUMBER DATE NAME CLASS SUBCLASS INITIAL IF APPROPRIATE 4,491,860 01/1985 Lim 4,740,485 04/1988 Sharpe-Geisler 4,783,424 04/1997 Ohno et al. 4,796,075 01/1989 Whitten 5,589,706 12/1996 Mitwalsky et al. 04/1997 5,618,750 Fujuhara et al. 5,625,218 04/1997 Yamadera et al. 5,914,524 06/1999 Komenaka 5,990,537 11/1999 Endo et al. 08/2001 6,277,674 B1 Wang et al. FOREIGN PATENT DOCUMENTS Translation DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Fukuda, Yukio, et al., A New Fusible-Type Programmable Element Composed of Aluminum and Polysilicon. IEEE Transactions on Electron Devices, Vol. ED-33, No. 2, Feb. 1986. **EXAMINER** DATE CONSIDERED EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conforman

not considered. Include copy of this form with next communication to the applicant.